## **EAST Search History**

## **EAST Search History (Prior Art)**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	10/599726	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 09:37
L3	47	"5416041"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 09:53
L4	11407	under adj etch\$4 under-etch\$4 under near etch\$4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:03
L5	9	4 same ( depth height) same ( half near3 ( thickness thick\$4))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:04
L6	31858	silicon-on-insulator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:05
L7	0	5 and 6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:05
L8	1	5 and SOI	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:05
L9	4803	(438/424-428).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:20

L10	3003	(438/424,425).OCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:21
L11	4803	9 10	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:21
L12	426	(257/513).OCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:21
L13	5832	(257/e21.552, e27.112).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:22
L14	883	(257/e21.552).OCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:22
L15	4960	(257/e27.112).OCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 10:22
L16	2	9 and 5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:23
L17	2	4 and 16	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:24
L18	80434	( rounded round\$4 ) near3 edge	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:25
L19	1	17 and 18	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:26

L27	1	12/613275	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/14 10:52
L29	520	,	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2010/12/14 11:07

## **EAST Search History (Interference)**

Ref#	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L20	5410	under adj etch\$4 under-etch\$4 under near etch\$4	USPAT; UPAD	OR	ON	2010/12/14 10:26
L21	4	20 same ( depth height) same ( half near3 ( thickness thick\$4))	USPAT; UPAD	OR	OFF	2010/12/14 10:27
L22	26326	silicon-on-insulator SOI silicon near3 on near3 insulator	USPAT; UPAD	OR	OFF	2010/12/14 10:28
L23	40770	( rounded round \$4 ) near3 edge	USPAT; UPAD	OR	ON	2010/12/14 10:28
L24	4	20 and 21	USPAT; UPAD	OR	ON	2010/12/14 10:28
L25	0	21 and 23	USPAT; UPAD	OR	ON	2010/12/14 10:28
L26	0	12/613275	USPAT; UPAD	OR	ON	2010/12/14 10:52
L28	1475	20 same ( region portion )	USPAT; UPAD	OR	OFF	2010/12/14 11:07
L30	2	28 same ( depth height) same ( half near3 ( thickness thick\$4))	USPAT; UPAD	OR	OFF	2010/12/14 11:08
L31	0	23 and 30	USPAT; UPAD	OR	OFF	2010/12/14 11:08
L32	2	28 same ( depth height) same ( half near3 ( thickness thick\$4))	USPAT; UPAD	OR	ON	2010/12/14 11:33
L33	0	23 and 32	USPAT; UPAD	OR	ON	2010/12/14 11:34

12/14/10 11:34:29 AM

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